

2828

PATENT
83371,0002#5/elec
Am
11/10/B

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Hideo SHIOZAWA, et al.

Serial No: 09/990,671

Filed: November 15, 2001

For: SEMICONDUCTOR LASER, METHOD
FOR FABRICATING THEREOF, AND
METHOD FOR MOUNTING THEREOF

Art Unit: 2828

Examiner: James W. Davie

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Date

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
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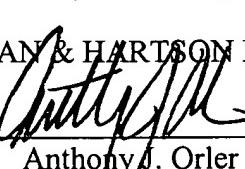
Dear Sir:

In response to the Restriction Requirement dated September 29, 2003, Applicant elects for prosecution the claims of Group I, Claims 1-8 and 10 without traverse.

If there are any fees due in connection with the filing of this response, please charge the fees to our Deposit Account No. 50-1314.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By: 

Anthony J. Orler
Registration No. 41,232
Attorney for Applicant(s)

Date: October 28, 2003

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